

IFW

PATENT
Docket No. 20067/OPP031054US

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant(s):

Date-Gun Lee

U.S. Serial No.: 10/734,808

For: "Methods to Fabricate a
Semiconductor Device"

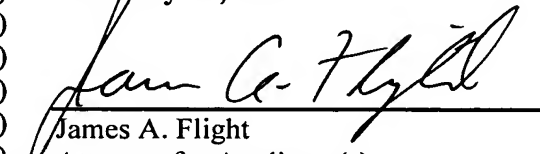
Filed: December 12, 2003

Group Art Unit: 2812

Examiner: Not Yet Assigned

) I hereby certify that this paper and the
) documents referred to as enclosed
) therewith are being deposited with the
) United States Postal Service as first
) class mail, postage prepaid, in an
) envelope addressed to Commissioner
) for Patents, P.O. Box 1450,
) Alexandria, Virginia 22313-1450 on
) this date:

) **February 14, 2005**

) 
) **James A. Flight**
) Attorney for Applicant(s)
) Registration No. 37,622

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced
matter.

Respectfully submitted,

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February 14, 2005

By:


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